



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ellison et al.

Application No.: 10/526,059

Filed: October 13, 2005

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: Attorney Docket: 31257-252090
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: Art Unit: 4174
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: Examiner: N. Gugliotta

Title: LIGHTLY DOPED SILICON CARBIDE WAFER AND USE THEREOF IN HIGH
POWER DEVICES

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the office action issued November 15, 2007, please amend the above-
identified application as follows: